

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : BREITSCHWERDT et al.
Serial No. : To Be Assigned
Filed : Herewith
For : DEVICE AND METHOD FOR ETCHING A SUBSTRATE BY
USING AN INDUCTIVELY COUPLED PLASMA

Art Unit : To Be Assigned
Examiner : To Be Assigned

Box Patent Application
P.O. Box 1450
Commissioner for Patents
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

SIR:

Please amend without prejudice the above-identified application before examination,
as set forth below.

In The Specification:

Page 1, line 2, after the title, please insert the following paragraph:

-- CROSS-REFERENCE TO RELATED APPLICATION

This application is a divisional of prior application Serial No. **09/871,224**, filed
May 31, 2001.

In The Claims:

Without prejudice, please cancel original claims 1 to 9 and 20.

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